

## Polishing and coating specification for Input Mode Cleaner End mirror of Advanced Virgo

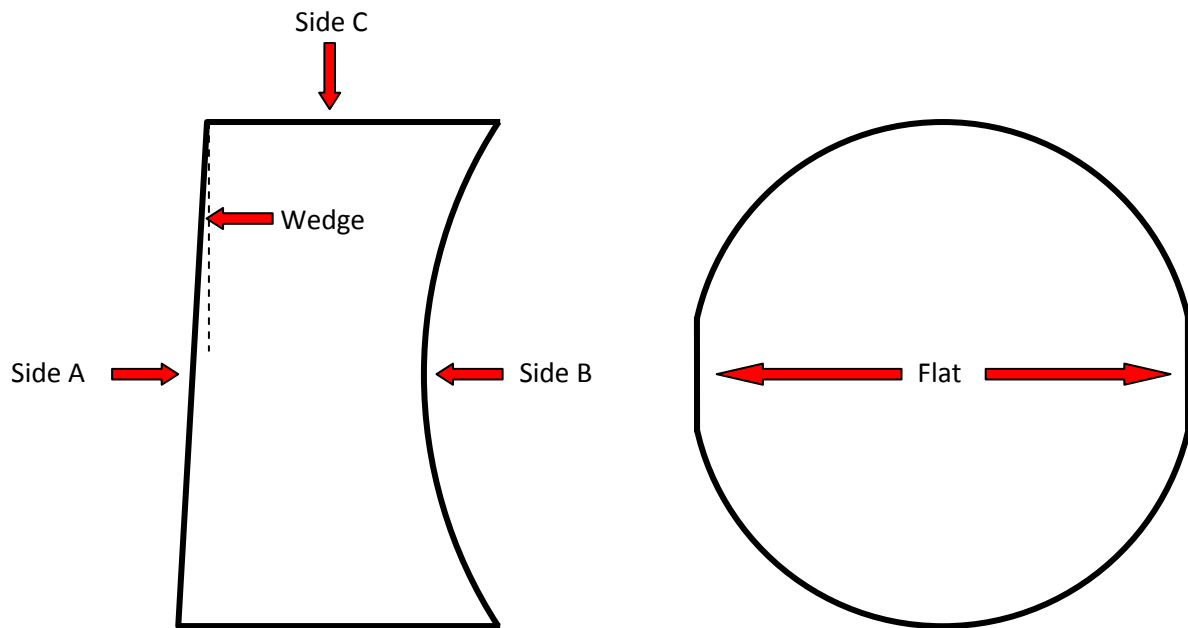
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Version: 8

### General parameters

| <b>Mirror Substrates</b> |   |  |                  |
|--------------------------|---|--|------------------|
| Material                 | Herasil 102   |  |                  |
| Outside diameter (mm)    | 145 ± 0.1   |  |                  |
| Thickness (mm)           | 90 +4/-0  |  |                  |
| Bevel                    | 0.5 to 1 mm x 45°   |  |                  |
| Wedge (mrad)             | 1 ± 0.2 on side A   |  |                  |
| Flat (mm)                | 20 ± 1 on side C  |  |                  |
| <b>Polishing</b>         |   |  |                  |
|                          | Side A<br>(AR surface)  | Side B<br>(HR surface)   | Side C<br>(side) |
| Curvature                | Residual ROC > 1km  | See section:<br><i>Radius of curvature</i>                                     |                  |
| Surface error (RMS)      | < 20 nm on 50mm diameter  | < 0.57nm<br>See section: <i>Surface error</i>                                  | polished         |
| Surface defects          | <= 10 scratches on 145mm diameter<br><= 5 digs on 145mm diameter          |  |                  |
| Roughness (RMS)          | < 10 Å on 50mm diameter   | < 3 Å ( $10^4$ - $10^6$ m <sup>-1</sup> )<br>See section: <i>Surface error</i> |                  |
| <b>Coating</b>           |   |  |                  |
| Wavelength (nm)          | 1064 + 680  | 1064   |                  |
| Coating type             | AR @ 0° at 1064nm on 140mm Diameter<br>R @ 15° at 680nm on 140mm diameter | HR @ 0° on 140mm diameter  | none             |
| Polarization             | S   | S  | NA               |
| Reflection               | > 0.7 at 680nm<br>< 1000ppm at 1064nm                                     |  | NA               |
| Transmission             |   | 1 ppm < T < 2 ppm  |                  |
| Absorption               | < 10ppm   | < 1ppm   |                  |
| Scattering               | < 5 ppm   | See section: <i>Surface error</i>  |                  |

An etched mark on Side C is required in order to give reference orientation for metrology



## Radius of curvature

### First requirement

Radius of curvature weighted by a Gaussian function:

$$I = e^{-\frac{2r^2}{\omega^2}}$$

Where  $r$  is the distance from the mirror center and  $\omega = 10.8mm$ .

N.B. For initial assessment of specification, the RoC can be estimated by a simple fit over an aperture diameter of 33mm instead of the Gaussian weighting.

**Radius of curvature in ordinary and extraordinary axis → 187m +0m -1m**

### Second requirement

**Radius of curvature in ordinary and extraordinary axis using a quadratic fit over all aperture diameters from 33mm to 140mm → 187m +0m -1m**

## Surface error

The surface error is specified using the power spectral density plotted in figure 1

This is a “2D PSD” i.e. the integration of the whole curve gives the square rms of the surface.

Power spectral density weighted by a Gaussian function:

$$I = e^{-\frac{2r^2}{\omega^2}}$$

Where  $r$  is the distance from the mirror center and  $\omega = 10.8mm$ .

N.B. For initial assessment of specification, the RoC can be estimated by a simple fit over an aperture diameter of 33mm instead of the Gaussian weighting.

The total rms of the given PSD is 0.57nm

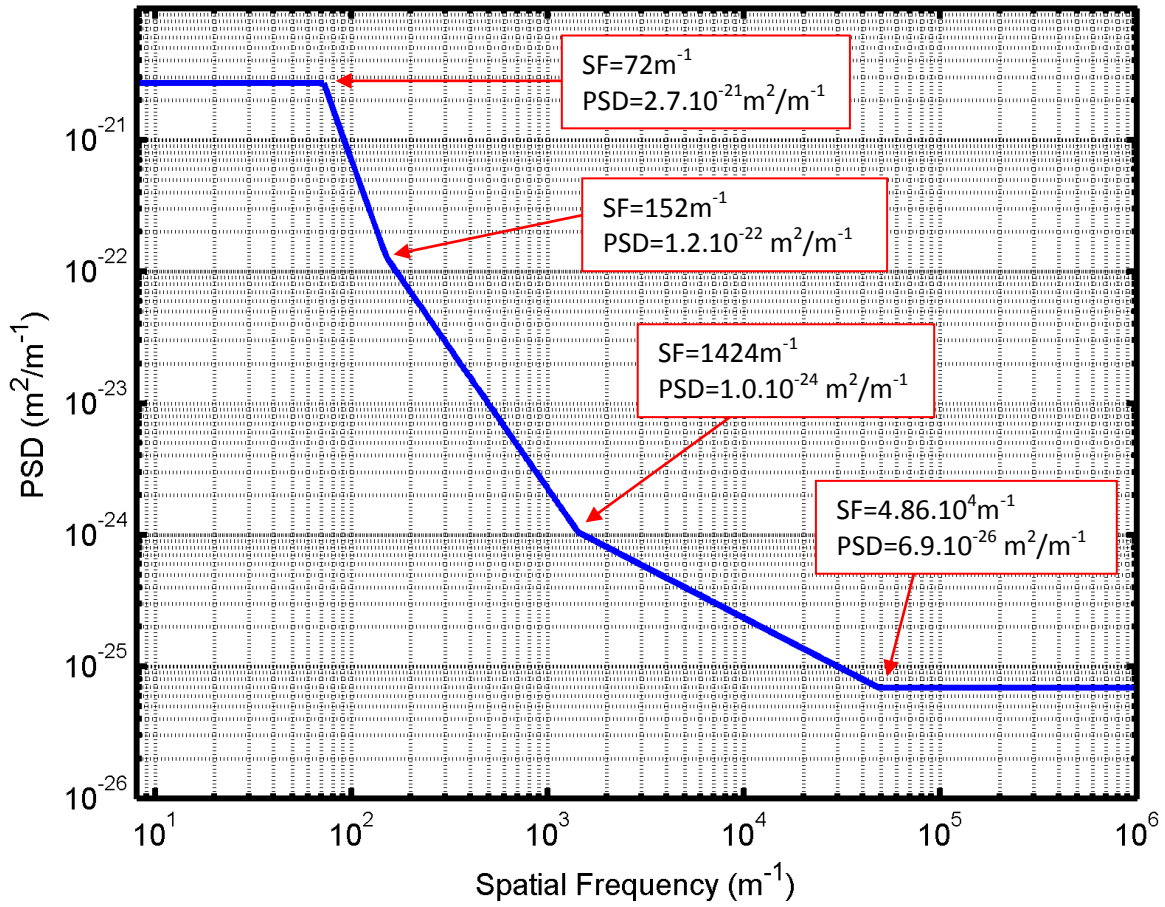


Figure 1. Power Spectral Density specification for side B of the substrate.